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D. M. J. J.
12-501

Docket No.: M4065.0319/P319-A
RECEIVED (PATENT)

NOV 26 2001
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TC 2800 MAIL ROOM

In re Patent Application of:
Husam N. Al-Shareef, et al.

Application No.: 09/912,558

Group Art Unit: 2813

Filed: July 26, 2001

Examiner: Not Yet Assigned

For: FABRICATION OF DRAM AND OTHER
SEMICONDUCTOR DEVICES WITH
AN INSULATING FILM USING A WET
RAPID THERMAL OXIDATION
PROCESS

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents
Washington, DC 20231

Dear Sir:

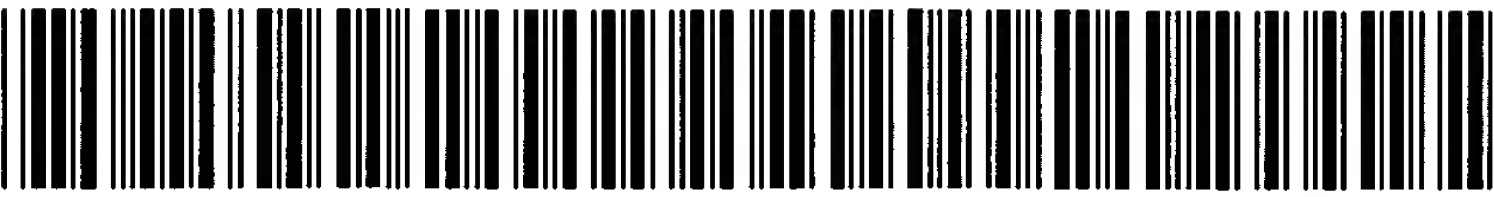
Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned.

A copy of each reference on PTO/SB/08 is attached.

A concise explanation of relevance of the items listed on form PTO/SB/08 is:

[X] not given



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2	EXIN	3

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